

Receipt date: 02/12/2009

Doc code: IDS

Doc description: Information Disclosure Statement (IDS) Filed

10785618 - GALL 2613  
Pro Series 40-1-03

Approved for use through 02/28/2009. OMB 0651-0031

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**  
( Not for submission under 37 CFR 1.99)

Application Number	10785618
Filing Date	2004-02-23
First Named Inventor	Christopher M. Look
Art Unit	2613
Examiner Name	Leung, Wai Lun
Attorney Docket Number	8433P009

U.S.PATENTS						<input type="button" value="Remove"/>
Examiner Initial*	Cite No	Patent Number	Kind Code <sup>1</sup>	Issue Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
	1	5627925		1997-05-06	Alferness et al.	
	2	5867289		1999-02-02	Gerstel et al.	
	3	5970201		1999-10-19	Anthony et al.	
	4	6332055	B1	2001-12-18	Hatayama et al.	
	5	6801679	B2	2004-10-05	Koh et al.	

If you wish to add additional U.S. Patent citation information please click the Add button.

**U.S.PATENT APPLICATION PUBLICATIONS**

Examiner Initial*	Cite No	Publication Number	Kind Code <sup>1</sup>	Publication Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
	1	20040208574	A1	2004-10-21	Kinoshita et al.	

If you wish to add additional U.S. Published Application citation information please click the Add button.

**FOREIGN PATENT DOCUMENTS**

Receipt date: 02/12/2009

Application Number	10785618	10785618 - GAU: 2613
Filing Date	2004-02-23	
First Named Inventor	Christopher M. Look	
Art Unit	2613	
Examiner Name	Leung, Wai Lun	
Attorney Docket Number	8433P009	

Examiner Initial*	Cite No	Foreign Document Number <sup>3</sup>	Country Code <sup>2</sup> <sup>1</sup>	Kind Code <sup>4</sup>	Publication Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear	T <sup>5</sup>
1								<input type="checkbox"/>

If you wish to add additional Foreign Patent Document citation information please click the Add button **NON-PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>5</sup>
1			<input type="checkbox"/>

If you wish to add additional non-patent literature document citation information please click the Add button **EXAMINER SIGNATURE**

Examiner Signature	/Danny Wai Lun Leung/	Date Considered	09/14/2010
--------------------	-----------------------	-----------------	------------

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through a citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> See Kind Codes of USPTO Patent Documents at [www.USPTO.GOV](http://www.USPTO.GOV) or MPEP 901.04. <sup>2</sup> Enter office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>3</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>4</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. <sup>5</sup> Applicant is to place a check mark here if English language translation is attached.